



INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

## ELECTRONIC COPY

### LABORATORY GROWN DIAMOND REPORT

October 12, 2024

IGI Report Number **LG659443017**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **CUT CORNED RECTANGULAR MODIFIED BRILLIANT**

Measurements **9.06 X 6.24 X 4.09 MM**

#### GRADING RESULTS

Carat Weight **2.00 CARATS**

Color Grade **H**

Clarity Grade **VVS 2**

#### ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

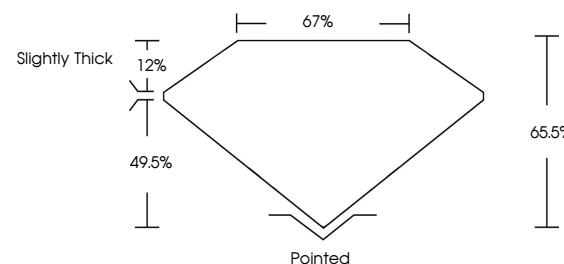
Inscription(s) **IGI LG659443017**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

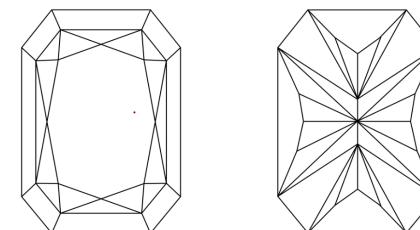
Type IIa

LG659443017  
Report verification at [igi.org](http://igi.org)

#### PROPORTIONS



#### CLARITY CHARACTERISTICS



#### KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

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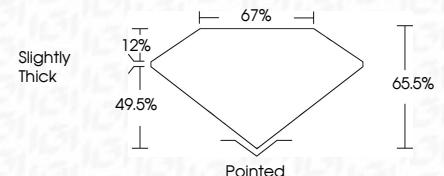
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Sample Image Used



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[www.igi.org](http://www.igi.org)

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October 12, 2024	IGI Report No. LG659443017	CUT CORNED RECT. MODIFIED BRILLIANT
9.06 X 6.24 X 4.09 MM	2.00 CARATS	H
Color Grade	VS 2	66.5%
Clarity Grade	67%	Pointed
Depth	49.5%	EXCELLENT
Table	12%	EXCELLENT
Grade	65.5%	NONE
Culet	Slightly Thick	IGI LG659443017
Polish		
Symmetry		
Fluorescence		
Inscription(s)		

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**IGI**